20	21	ch	· N	10	tes
JE	a i	CII			LCS



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/637,663	ITOH ET AL.	
Examiner	Art Unit	
Steven D. Padosovich	2138	

SEARCHED				
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Class search: 702/117 text search attached	4/11/2006	SDR	
Reviewed the China patent references cited list to locate art not found by examiner. References cited attached	4/11/2006	SDR	
Cynthia Britt: help with final and NPL not included in applicants IDS	4/17/2006	SDR	